ADDITIONA FEE
\$36
\$0
\$0
\$420
\$0
\$456

Daniel R. McClure, Reg. No. 38,962

Aug 23, 20 d 4

Date

JAN 2818/



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Sheng Hsiung Chen

Confirmation Number: 3764

Serial No.: 09/905,408

Group Art Unit: 2818 Examiner: Berry, Renee

Filed: 07/16/2001

TKHR Docket No. 252016-1130

Top-Team Ref. 0503-A30726US

For:

SELECTIVE FORMATION OF METAL GATE FOR DUAL GATE OXIDE

APPLICATION

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 23, 2004.

Signature – Hui Chin Barnhill

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop –Amendment Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The Office Action mailed March 29, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

08/26/2004 WASFAW1 00000014 09905408

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